

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Senkevich et al.

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Serial No.: 10/531,245

Group Art Unit: 1722

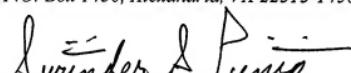
Filed: April 14, 2005

Examiner: Seyed M. Malekzadeh

Title: ATOMIC LAYER DEPOSITION OF NOBLE METALS

CERTIFICATE OF TRANSMISSION

I certify that this document is being deposited on July 23, 2007 in the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 or is transmitted by electronic filing to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



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Date of Signature: July 23, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450
Attn.: Seyed M. Malekzadeh

RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the Office Action mailed on February 23, 2007, in connection with the above-identified U.S. patent application. In light of a petition for a two-month extension and fee therefore, enclosed herewith, the period for response

on July 23, 2007. This response is timely filed.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper. **Remarks/Arguments** begin on page 6 of this paper.